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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: OZAKI, Takashi, et al.

Group Art Unit: 1792

Serial No.: 10/528,137

Examiner: MACARTHUR, Sylvia

Filed: December 12, 2005

P.T.O. Confirmation No.: 2307

For: SUBSTRATE PROCESSING APPARATUS AND METHOD FOR
MANUFACTURING A SEMICONDUCTOR DEVICEPETITION FOR EXTENSION OF TIMECommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: March 12, 2009

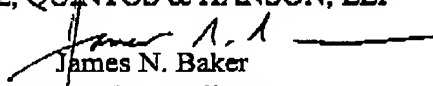
Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated October 2, 2008 for three months, from January 2, 2009 to April 2, 2009.

Applicants filed a Petition for One-Month Extension of Time and the fee was paid on January 23, 2009. Accordingly, the Commissioner is authorized to charge our Deposit Account in the amount of \$980.00 to cover the remaining cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

KRATZ, QUINTOS & HANSON, LLP


James N. Baker
Agent for Applicant
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JNB/ak

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PATENT & TRADEMARK OFFICE